

Special Issue

Electrochemical Deposition and Characterization of Thin Films

Message from the Guest Editors

The past decades have seen intensive improvement in thin film deposition methods. Today, it is possible to coat surfaces with complex compositions and synthesize multilayers, enabling the development of synergistic effects through the mutual interaction of such layers. The deposition of complex structures allows for the development of new technologies, with recent advances in deposition techniques further miniaturizing electronic devices. The development of these new technologies toward scaling down the size of the produced devices requires accurate control of the deposition process. The latter then allows tailoring thin films and nanodevices to one's desire. Recent advances are not only limited to nanoelectronics but are applicable to every field, viz., anti-corrosion coating, biocidal coating, or photovoltaic devices, in order to cope with the present demands of society. This Special Issue invites researchers studying subjects related to electrochemical deposition, film characterization using various methods, as well as any other related subjects to submit full research papers, short communications, and review articles.

Guest Editors

Prof. Dr. Anca Cojocaru

Department of Inorganic Chemistry, Physical Chemistry and Electrochemistry, Faculty of Chemical Engineering and Biotechnologies, University Politehnica of Bucharest, Bucharest, Romania

Dr. Ioana Maior

Department of Inorganic Chemistry, Physical Chemistry and Electrochemistry, Faculty of Chemical Engineering and Biotechnologies, University Politehnica of Bucharest, Bucharest, Romania

Deadline for manuscript submissions

closed (20 November 2023)



Materials

an Open Access Journal
by MDPI

Impact Factor 3.2
CiteScore 6.4
Indexed in PubMed



mdpi.com/si/126396

Materials
Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland
Tel: +41 61 683 77 34
materials@mdpi.com

[mdpi.com/journal/
materials](https://mdpi.com/journal/materials)





Materials

an Open Access Journal
by MDPI

Impact Factor 3.2
CiteScore 6.4
Indexed in PubMed



[mdpi.com/journal/
materials](https://mdpi.com/journal/materials)



About the Journal

Message from the Editor-in-Chief

Materials (ISSN 1996-1944) was launched in 2008. The journal covers twenty-five comprehensive topics: biomaterials, energy materials, advanced composites, advanced materials characterization, porous materials, manufacturing processes and systems, advanced nanomaterials and nanotechnology, smart materials, thin films and interfaces, catalytic materials, carbon materials, materials chemistry, materials physics, optics and photonics, corrosion, construction and building materials, materials simulation and design, electronic materials, advanced and functional ceramics and glasses, metals and alloys, soft matter, polymeric materials, quantum materials, mechanics of materials, green materials, general. *Materials* provides a unique opportunity to contribute high quality articles and to take advantage of its large readership.

Editor-in-Chief

Prof. Dr. Maryam Tabrizian

1. Department of Biomedical Engineering, Faculty of Medicine and Health Sciences, McGill University, Montreal, QC H3A 2B6, Canada
2. Faculty of Dentistry and Oral Health Sciences, McGill University, 3640 Rue University, Montreal, QC H3A 0C7, Canada

Author Benefits

Open Access:

free for readers, with article processing charges (APC) paid by authors or their institutions.

High Visibility:

indexed within Scopus, SCIE (Web of Science), PubMed, PMC, Ei Compendex, CaPlus / SciFinder, Inspec, Astrophysics Data System, and other databases.

Journal Rank:

JCR - Q2 (Metallurgy and Metallurgical Engineering) /
CiteScore - Q1 (Condensed Matter Physics)